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F-9223

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Akira OKABE, et al.
Serial No. : (U.S. National Stage of PCT/JP2004/016567
Filed November 9, 2004)
Filed : (Concurrently herewith)
For : WAFER SUPPORT AND SEMICONDUCTOR
SUBSTRATE PROCESSING METHOD
Group Art Unit : UNKNOWN
Examiner : UNKNOWN

September 27, 2006
New York, New York

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Attached hereto is a copy of Form PTO-1449 together with copies of the 15 references listed therein. Also enclosed is a copy of PCT/JP2004/016567 International Search Report listing 5 of the 15 references listed in Form PTO-1449.

Please note a concise explanation of the relevance of JP-10-223545 (equivalent to U.S. 6,129,047) and JP2002-198318 appear at page 4 of the specification.

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Also, a concise explanation of the relevance of JP-2003-273037 (equivalent to U.S. 6,887,775 and US Publication No. 2003/21998), JP-2003-197532, JP-2003-197533 and JP-2003-229370 appear at page 5 of the specification.

This Information Disclosure Statement is being filed prior to issuance of the first Official Action. Therefore, there is no charge for filing this IDS.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				Applicant: Akira OKABE, et al.				
				Filing Date: (Concurrently)		Group: (UNKNOWN)		
U.S. PATENT DOCUMENTS								
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	U1	US- 6,129,047 (Equivalent to JP 10-223545)	10/10/2000	Nakamura				
	U2	US- 6,887,775 (Equivalent to JP 2003-273037)	5/3/2005	Von Ammon et al.				
	U3	US- 2003/0219981 (Equivalent to JP 2003-273037)	11/27/2003	Ammon et al.				
	U4	US- 6,444,027	9/3/2002	Yang et al.				
	U5	US- 6,184,154	2/6/2001	Dietze et al.				
	U6	US- 5,370,709 (Equivalent to JP 4-075328)	12/6/1994	Kobayashi				
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	F1	JP- 10-223545 (Equivalent to US 6,129,047)	8/21/1998	JP			Y ^{*C}	
	F2	JP- 2002-198318	7/12/2002	JP			Y ^{*C}	
	F3	JP- 2003-273037 (Equivalent to US 6,129,047 and US Pub. 2003/219981)	9/26/2003	JP			Y ^{*C}	
	F4	JP- 2003-197532	7/11/2003	JP			Y ^{*C}	
	F5	JP- 2003-197533	7/11/2003	JP			Y ^{*C}	
	F6	JP- 2003-229370	8/15/2003	JP			Y ^{*C}	
	F7	JP- 4-075328 (Equivalent to US 5,370,709)	3/10/1992	JP			Y ^{*F}	
	F8	JP- 2002-134425	5/10/2002	JP			Y ^{*F}	
	F9	JP- 11-079888	3/23/1999	JP			Y ^{*F}	
TRANSLATION KEY: * English Abstract. ^F Concise statement of relevance provided in foreign search report. ^C Concise statement of relevance provided in specification or in attachment to document. ^S Concise statement of relevance provided in IDS. ^P Relevant portion of document translated. ^O English abstract only - copy of document in pct search.								

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
OTHER INFORMATION DISCLOSURE CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)								
EXAMINER				DATE CONSIDERED				
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								